L Number	Hits	Search Text	DB	Time stamp
1	21	3484534.URPN.	USPAT	2004/01/03
				12:24
_	2	(leadframe).ti. and (harrison).in.	USPAT;	2003/06/26
			US-PGPUB;	17:08
			EPO; JPO	
_	9	("4743956" "4974053" "5115298"	USPAT	2003/06/26
		"5138430" "5200364" "5313102"		17:05
		"5397916" "5457340" "5569956").PN.		1
	1387	1	USPAT;	2003/06/26
_	150,	Teadylliame and encapsulacys	EPO; JPO	17:09
	76	(lead\$1frame and encapsulat\$3) and	USPAT;	2003/06/26
-	/ 6	conductive adj1 pad	EPO; JPO	17:40
	535		USPAT;	2003/06/26
_	333		EPO; JPO	17:41
		conductive adj1 pad ("4575748" "4578697" "4789889").PN.	USPAT	2003/08/04
-	3	("45/5/48" "45/869/" "4/89889").PN.	USPAI	
		00/007 000 040 041 000 000 ==1 = 1	IICDAM -	13:14
-	360		USPAT;	2003/08/04
		lead\$1frame	EPO; JPO	13:56
-	155		USPAT;	2003/08/04
		lead\$1frame) and encapsulat\$3	EPO; JPO	13:57
_	6	1 =	USPAT;	2003/08/04
		arcuate	US-PGPUB	14:52
_	6	257/666-676.ccls. and lead\$1frame and	USPAT;	2003/08/04
		arcuate	EPO; JPO	14:52
-	42	257/666-676.ccls. and lead\$1frame and	USPAT;	2003/08/04
		spacing and constant	EPO; JPO	16:08
-	8	("3680206" "3936930" "3971610"	USPAT	2003/08/04
		"4000054" "4116517" "4403272"		16:07
		"4758459" "4813129").PN.		
_	1	4453795.pn.	USPAT;	2003/08/04
		-	EPO; JPO	16:08
_	45	5313096.URPN.	USPAT	2003/08/04
				16:20
_	55	5200362.URPN.	USPAT	2003/08/04
				16:37
_	9	("4743956" "4974053" "5115298"	USPAT	2003/08/04
	1	"5138430" "5200364" "5313102"	1	18:03
		"5397916" "5457340" "5569956").PN.	1	
_	9		USPAT	2004/01/02
		"3792383" "4064552" "4095412"		18:45
: :		"4144705" "4157007" "4241436").PN.		
_	4	4,142,287.pn. 4,405,242.pn.	USPAT;	2004/01/02
	1	1,112,20,1211. 1,100,212.211.	EPO; JPO	18:47
_	21	3484534.URPN.	USPAT	2004/01/02
_	21	JIUIJJI. UNEM.		18:48
	19	3617819.URPN.	USPAT	2004/01/02
_	19	301/019. ORFN.	JUSTAT	18:50
	10	3746932.URPN.	USPAT	2004/01/02
-	10	3/40932.UKPN.	USERI	18:51
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	U	1	Document	ID	Issue Date		Title	Current OR	Currer
5	Г	Γ	us 4974053	3 A	19901127	22	Semiconductor device for multiple packaging	257/666	257/78 257/E2
6	Г	Γ	us 4743956	5 A	19880510	5	Offset bending of curvaceously planar	257/674	216/14 257/E2
7	Г	┍	US 5158460	5 A	19921027	6	Metallically encapsulated elevated interconnection	439/67	29/846 439/86
8	Г	ᅜ	us 5036380) A	19910730	9	Burn-in pads for tab interconnects	257/668	257/48 257/73
9		ঘ	us 4774635	5 A	19880927	8	Semiconductor package with high density I/O lead	361/813	174/52 257/67
10	Г	ᅜ	us 4598331	7 A	19860701	8	Electronic circuit board for a timepiece	361/763	361/74 368/31
11	Г	₽	us 5589402	2 A	19961231	9	Process for manufacturing a package for mating with a	438/64	257/E2 29/827
12		ᅜ	us 527597	5 A	19940104	9	Method of making a relatively flat	438/15	257/E2 29/827
13	_	P	បន 520036	2 A	19930406	7	Method of attaching conductive traces to an	29/841	257/E2 257/E2
14	Г	乊	us 480701	8 A	19890221	5	Method and package for dissipating heat generated	257/675	257/73 257/E2
15		ᄝ	បន 593977	5 A	19990817	27	Leadframe structure and process for packaging	257/667	257/67 257/E2
16	Г	ঘ	us 445379	5 A	19840612	8	Cable-to-cable/component electrical pressure wafer	439/361	439/6
17	_	₽	us 348453	4 A	19691216	9	MULTILEAD PACKAGE FOR A MULTILEAD ELECTRICAL DEVICE	174/52.2	216/20 257/73
18	_	N.	บร 374693	2 A	19730717	11	PANEL BOARD SYSTEMS AND COMPONENTS THEREFOR	361/785	174/52 257/E2
19	_	F	us 451475	0 A	19850430	9	Integrated circuit package having interconnected leads	257/670	174/50 257/E0